



Attorney Docket No. 0756-7210

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Hirota OISHI
Serial No. 10/684,416
Filed: October 15, 2003
For: LASER IRRADIATION APPARATUS
AND METHOD OF
MANUFACTURING
SEMICONDUCTOR DEVICE BY
USING THE LASER IRRADIATION
APPARATUS

) Group Art Unit: 1725
) Examiner: Samuel M. Heinrich
) CERTIFICATE OF MAILING
) I hereby certify that this correspondence is
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) Commissioner for Patents, P.O. Box 1450,
) Alexandria, VA 22313-1450, on December 21,
) 2007.
) Adelle M. Stampler
)
)
)

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated August 22, 2007, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 9 of this paper.